

AT&TSEMICONDUCTORINDUSTRIAL HYGIENE AND SAFETY CONFERENCE

September 11-12, 1985
 AT&T Bell Laboratories
 600 Mountain Avenue
 Murray Hill, NJ 07974
 Rooms 6B-201, 6B-230

Hosted By:
 AT&T Bell Laboratories
 Industrial Hygiene and Safety
 Department/Environmental
 Health, Environmental Manage-
 ment, and Safety Center

TENTATIVE AGENDADay 1

8:00- 8:15	Arrival/Coffee	
8:15- 8:30	Welcome/Opening Remarks	G. M. Wilkening
8:30- 9:00	Toxicity of Semiconductor Gases	S. L. Malish
9:00- 9:30	Safe Handling of Hazardous Gases	D. Gittelman
9:30-10:00	Cylinder Leak Detection Methods/Demonstration	S. R. Eagles
	H ₂ Pipeline Upgrade	
10:00-10:15	Break	
10:15-11:15	Current Engineering Aspects and Demonstration	L. Varadi
	- Double Walled Piping	
	- Toxic Gas Cabinets/Monitors/Valves	
11:15-11:45	RD Hazard Communication Program	D. Reigle
11:45-12:45	Lunch	
12:45-2:55	Tours 1, 2, 3 (7-8 people per group)	

No. 1
3/4 hour
 Waste Packaging Facility
 Analytical Lab Tour
 R. M. Markow 4-276, 4-251

No. 2
3/4 hour
 Bldg. 4 Gas House/
 Laboratory Tour
 D. Johnston

No. 3
3/4 hour
 VLP Control Room/
 Roof Tour
 D. Raver

2:55- 3:10 Break

3:10- 4:10 Panel Discussion
 Spill Response Teams
 15 min. C. Strang - Start-up/Training of Proposed SRT
 15 min. R. Pollitt - ME Spill Response
 15 min. M. Zebora - EO Spill Response
 15 min. General Discussion

4:10- 4:40 FTIR-TELOS Interface
 Vacuum Oil Analysis
 C. Strang

4:40- 5:00 Fire Protection in Semiconductor Areas
 A. Lynch

5:30- 6:30 Hospitality Hour
 Dining Room

6:30- 8:30 Dinner